



IFW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q79849

Mikhail Abramovich GAN, et al.

Appln. No.: 10/779,859

Group Art Unit: 2873

Confirmation No.: 6217

Examiner: David N. SPECTOR

Filed: February 18, 2004

For: LENS SYSTEM, AND OBJECTIVE LENS SYSTEM AND OPTICAL PROJECTION  
SYSTEM USING THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Non-Final Office Action dated May 4, 2005, please amend the above-identified application as follows on the accompanying pages.

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